

EAST Search History**EAST Search History (Prior Art)**

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	457	terada-yoshio.in.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/08/26 12:47
L2	21	terada-yoshio.in. and polyimide	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/08/26 12:48
L3	38	terada-y\$.in. and polyimide	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/08/26 14:43
L4	16	namikawa-makoto. in. and polyimide	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/08/26 14:43
L5	17	namikawa-m\$.in. and polyimide	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/08/26 14:43
L6	13	uenda-d\$.in. and polyimide	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/08/26 14:44
L7	3	funatsu-a\$.in. and polyimide	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/08/26 14:44
L8	12	(releasable or protective) same ((cleaning adj1 layer) or polyimide) same (support or backing) same adhesive adj1 layer same (carrying or semiconductor or wafer or panel or display)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/08/26 14:46

L9	12	(releasable or protective) same ((cleaning adj1 layer) or polyimide) same (support or backing) same adhesive adj1 layer same (carrying or semiconductor or wafer or panel or display) and polyimide	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/08/26 14:52
L10	2	(releasable or protective) same (cleaning adj1 layer) same (support or backing) same adhesive adj1 layer same (carrying or semiconductor or wafer or panel or display) and polyimide	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/08/26 14:52

8/26/09 3:01:36 PM**C:\My Documents\EAST\Workspaces\%lorna.wsp**